



| FORM PTO-144 MODIFIED | | | Docket No.: 2437.09US04 | Application No.: 10/077,180 | | |
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| INFORMATION DISCLOSURE CITATION IN AN APPLICATION | | | APPLICANT: HIATT et al. FILING DATE: February 15, 2002 GROUP ART UNIT: 3729 | | | |
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| EXAMINER SIGNATURE | | | DATE CONSIDERED | | | |
| <i>A. DEXTER TUGBANO</i> | | | 7/11/05 | | | |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. not in conformance and not considered. Include copy of citation with next communication to the applicant. | | | | | | |

PRIMARY EXAMINER



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| FORM PTO-1449 MODIFIED INFORMATION DISCLOSURE CITATION IN AN APPLICATION | | Docket No.: 2437.09US04 | Application No.: 10/077,180 |
| | | APPLICANT: HIATT et al. | |
| | | FILING DATE: February 15, 2002 | |
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